

Application Data Sheet

Inventor Information

Inventor One Given Name: Shuichi
Family Name: KIKUCHI
Residence: Ora-gun, Gunma, Japan
Postal Address Line One: 30-6, Sumiyoshi
Postal Address Line Two: Oizumi-machi, Ora-gun
City: Gunma
State or Province: Japan
Postal or Zip Code:
Citizenship Country: JAPAN

Inventor Two Given Name: Masaaki
Family Name: MOMEN
Residence: Ojiya-shi, Niigata, Japan
Postal Address Line One: Chiyajimaryou
Postal Address Line Two: 3030 Chiya koh
City: Ojiya-shi
State or Province: Niigata
Postal or Zip Code:
Citizenship Country: JAPAN

Correspondence Information

Name Line One: Barry E. Bretschneider
Name Line Two: Morrison & Foerster LLP
Address Line One: 1650 Tysons Boulevard
Address Line Two: Suite 300
City: McLean
State or Province: Virginia
Postal or Zip Code: 22102
Telephone: (703) 760-7743
Fax: (703) 760-7777
E-mail: bbretschneider@mofo.com

Application Information

Title Line One: METHOD OF MANUFACTURING SEMICONDUCTOR
DEVICE (AS AMENDED)
Total Drawing Sheets: 5
Formal Drawings?: yes
Application Type: Utility
Docket Number: 492322006510

Representative Information

Representative Customer Number: 25227

Prior Foreign Applications

This Application is a Divisional of:

Application Number:	10/215,188
Filing Date:	August 9, 2002

Prior Foreign Application One:	2001-243725
Filing Date:	August 10, 2001
Country:	Japan
Priority Claimed:	yes